



DAQ/FEE/Trigger
for COMPASS beyond 2020 workshop,
CTU FNSPE Prague, November 9-11, 2017

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Activities of LTU for high energy physics experiments

*LED Technologies of Ukraine:
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Maksym Protsenko (speaker)
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Outline

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- ❖ LTU /Kharkiv team and activities
- ❖ Activities for physics experiments
- ❖ Features of the approach
- ❖ Background
- ❖ Activities for Compass
- ❖ Other activities
- ❖ Conclusions

LTU/Kharkiv team and activities

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- *brief information about team:*
 - ❖ *staff of team: ~25 persons (incl. 2 Professors, 3 Doctors)*
 - ❖ *leader of team: Prof. Dr. Vyacheslav (Slava) Borshchov*
 - ❖ *leading experts: Ihor Tymchuk, Maksym Protsenko*
 - ❖ *production area: ~ 500 sq.m.*
 - ❖ *departments/sites: microcables production site and assembly site*
 - ❖ *year 2013 – team is passed from SE SRTIIE to LTU*

- *main activities of team:*
 - ❖ *engineering for physics experiments*
 - ❖ *space engineering (solar arrays, flexible heaters, etc.)*
 - ❖ *terrestrial photovoltaics (concentrator photovoltaic)*
 - ❖ *indoor and outdoor LED lighting*

Activities for physics experiments

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- Designing detector modules
- Designing components of the modules (single- and multilayered flexible cables and flexible-rigid boards etc.)
- Designing photomasks
- Manufacture of the components
- Developing assembly procedures for detector modules and their components
- Developing, designing and manufacturing precise assembly jig
- Implementing assembly processes at assembly sites (if necessary)
- Reliability tests of the components

Notes:

- ✓ *work „Development and implementation in industry of newest technologies of ultramodern detector modules creation on the basis of hi-tech base components with aluminium interconnection for particles detector systems in high energy physics experiments” submitted by Kharkiv team was awarded by the Ukrainian Government for the development and implementation of innovative technologies (April 6, 2016)*
- ✓ *More than 80 papers on activities for physics experiments are published*

Features & advantages of „full-aluminium” approach

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Features:

- *Materials for the components:*
 - *conductive layers* - *aluminium-polyimide adhesiveless foiled dielectrics*
 - *dielectric spacer* – *Kapton or polyimide*
- *Layers manufacture techniques:* *photolithography & chemical wet etching*
- *Assembly techniques:* *SpTAB&gluing*

Advantages:

- *approach is **verified** in practice in existing ALICE ITS strip and drift detector modules*
- *conductive layer is **aluminium***
- ***lower material budget** (compared to Cu)*
- ***absence of heavy metals** (Au, Sn) on the flex and on the chip (soldering is not needed)*
- *connection of aluminium leads of the flex to aluminium contact pads of the chip that ensure **high-reliable and mechanically stable connections**;*
- *possibility to realize **3-D (volumetric) design** of the module/component*
- *high-precise and high-throughput standard **automated equipment** can be used for assembly (Delvotec G4, G5 bonders etc.). Tune of the bonder is very simply and can be done in few hours!*

Feature of the approach: chipcable

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Chipcable- cable welded to chip/sensor for further connection to flex.

Cable allows to test chip/sensor after welding.

Plastic frame (TAB-35, TAB-70) for cable and chip+cable tests is using

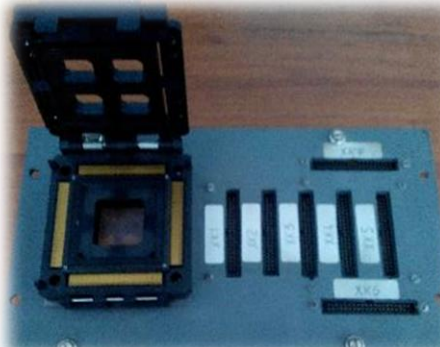
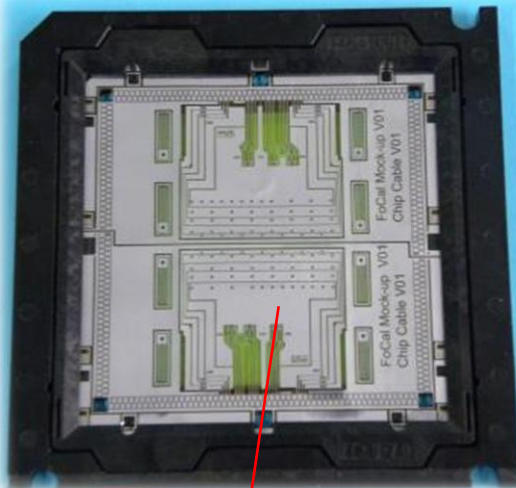
Usage of chipcables allow to use for further assembly only good chips/sensors.

TAB-70 (2xFoCal chipcable)

Test Socket (TAB-70)

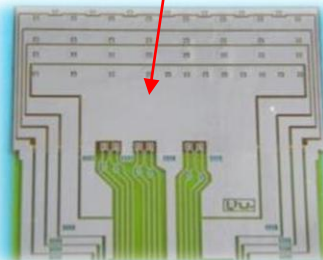
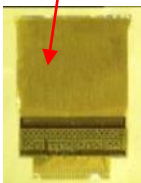
TAB-35 (1xALICE chipcable)

Framed
cables



FoCal chipcables in test Socket (TAB-70)

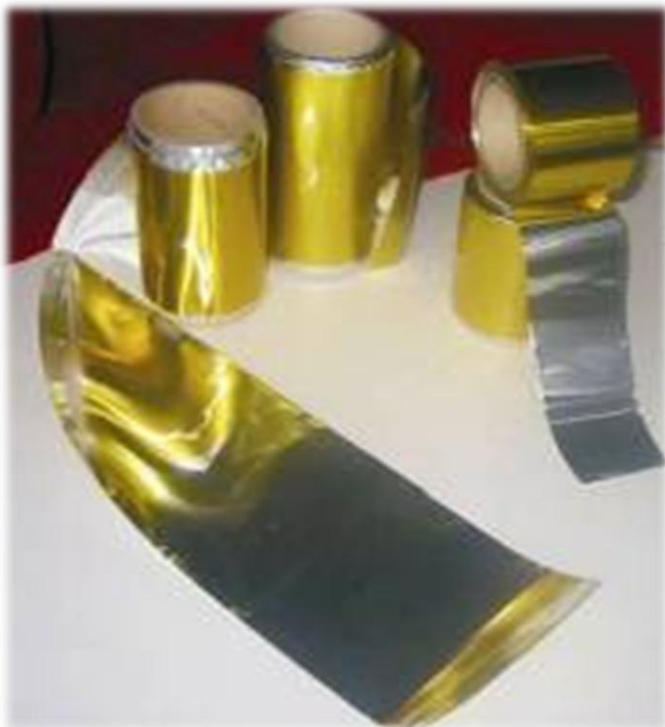
Cut-off
work areas
with chips



Materials and technological level

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Main materials for flexible layers are aluminium-polyimide adhesiveless foiled dielectrics FDI-A type



❖ **FDI-A-24**

polyimide
aluminium foil

– 10 *um*
– 14*um*

❖ **FDI-A-50**

polyimide
aluminium foil

– 20 *um*
– 30 *um*

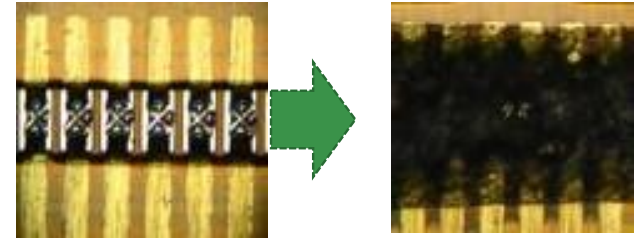
<u>Fine-pitch cables</u> FDI-A-24	pitch of traces	45÷60 <i>um</i>
	width of traces	20 ÷ 30 <i>um</i>
	length of cable	10 ÷ 20 mm
	quantity of traces	128÷1024
<u>Connecting cables, flexes</u> FDI-A-24 FDI-A-50	pitch of traces	100÷200 <i>um</i>
	width of traces	40 ÷ 100 <i>um</i>
	length of cable	up to 600 mm
	quantity of traces	up to 512



Some features of assembly process

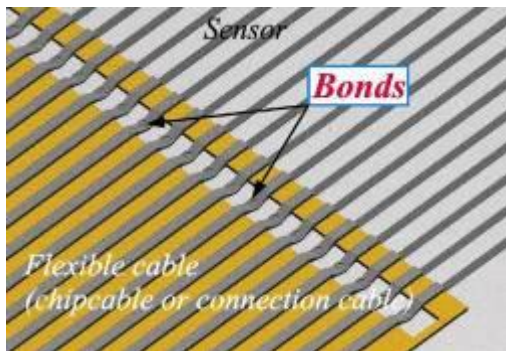
8

Main process at modules components assembling is an ultrasonic TAB bonding (manual or automatic) of aluminium traces to contact pads on chip, sensor or flexible cable with encapsulating by glue

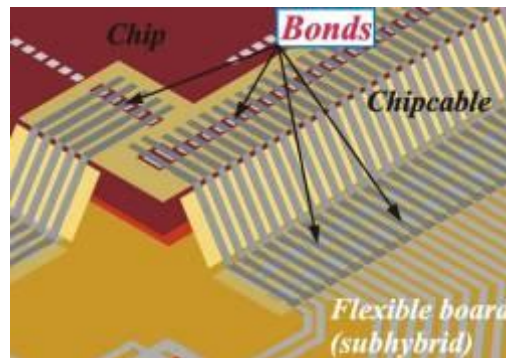


Schematic close-up view of some different connection areas

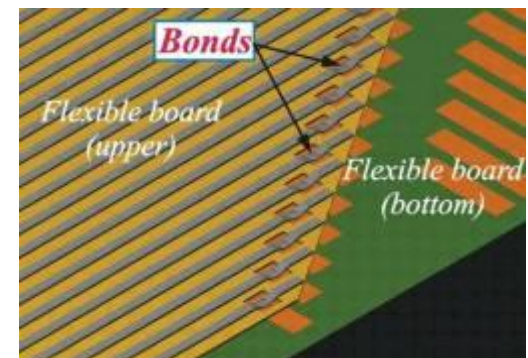
cable-to-sensor



chipcable-to-chip & chipcable-to-subhybrid



flexible board-to-flexible board (inside subhybrid)



Note: for SpTAB techniques two times less bonds are required- higher reliability

Features of typical multilayered flex

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- Flex consist of three layers: top, spacer, bottom
- Layers of the flex are manufactured based on photolithography and chemical wet etching technological processes
- Typical assembly sequence includes following main operations: multilayered flexible board gluing and bonding (TAB), board-to-chip bonding (TAB), bond joints protecting by glue
- Typical flex might includes following types of TABed joints:

- *Top layer-to-chip*



- *Bottom layer-to-chip*



- *Interlayer connection*

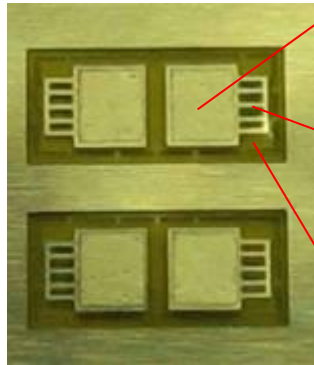


Some features of SMD components and SMT connectors mounting

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For manufacturability increasing SMD components and SMT connectors are mounting on flexible carriers (flex-mounts) by soldering and after that connecting to board or cable by ultrasonic bonding

Flex-mounts for SMD component

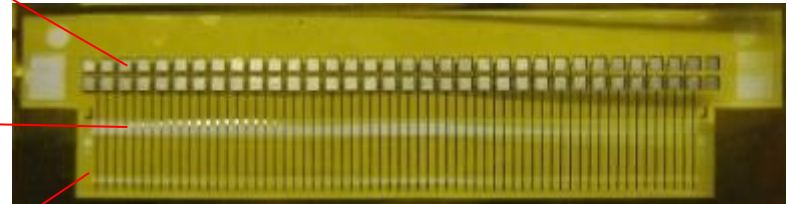


Ni + SnBi layer (pads for soldering)
Thickness ~ 3+8 μm

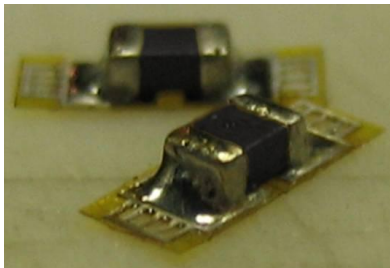
Aluminum layer (traces for bonding)
Thickness ~ 30 μm

Polyimide layer
Thickness ~ 20 μm

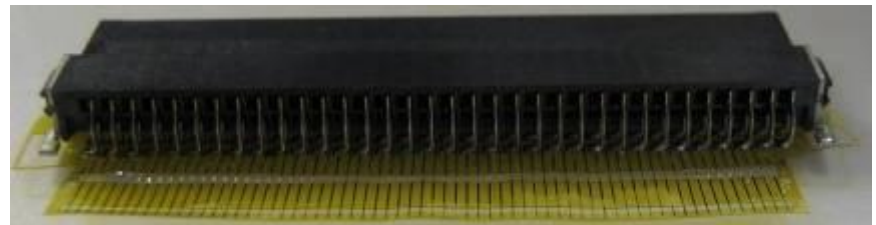
Flex-mount for SMT connectors



SMD resistor on flex-mount



Dual row connector on flex mount



Background:

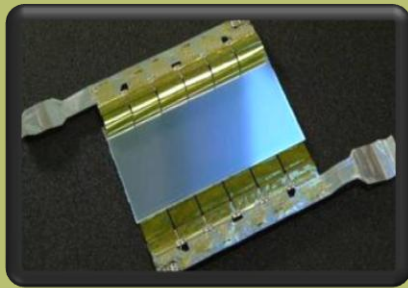
ALICE ITS SSD&SDD detector modules

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For existing ALICE ITS by Kharkov team more than 200 types of module components developed and more than 50000 components manufactured and delivered for SSD and SDD modules creation

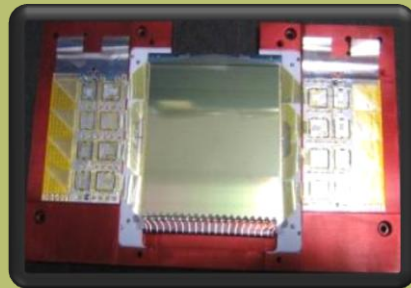
SSD

(&CERN, NIKHEF, IN2P3, HIP)



SDD






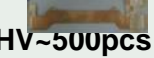
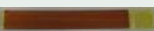
(&CERN, INFN)



For both module types were done :

- **Modules and components design developed**
- **Prototypes assembled and tested**
- **Full-scale production organized**
- **Assembly technologies developed and implemented at foreign assembly sites**
- **Components for more than 2000 SSD and 400 SDD modules manufactured and delivered**
- **Two foreign assembly sites organized for modules assembling**

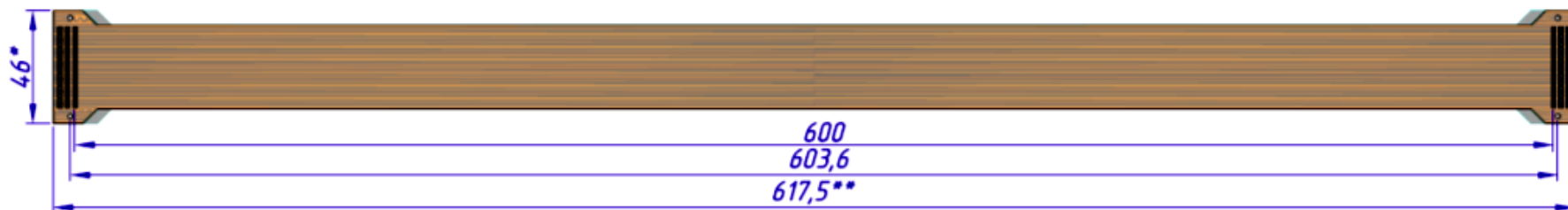
Developed and manufactured components for the modules

Type	Brief description	Manufactured components quantity	
		SSD	SDD
Chipcables	Single- and twochip single- and double layer ultralight flexible cables with min. pitch of traces 80-100um	~35000pcs 	~3000pcs 
Subhybrids	Flexible-rigid multilayered boards on the carbon fiber heat sink	~4500pcs 	~700pcs 
Long connecting cables	Connecting multilayered & HV cables (length up to 600mm, operating voltage up to 5kV)	~4500pcs LV 	LV~1500pcs HV~500pcs  

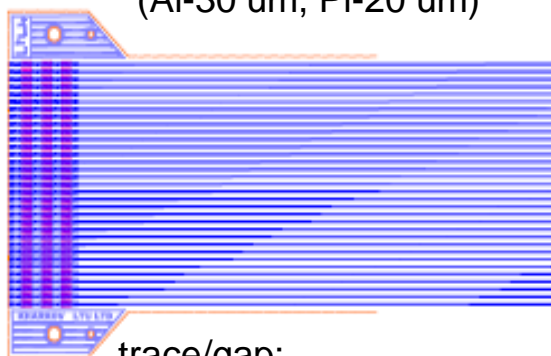
Activities for COMPASS

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Single- and multilayered flexible connecting cables



Compass cable
(Al-30 um, Pi-20 um)



trace/gap:

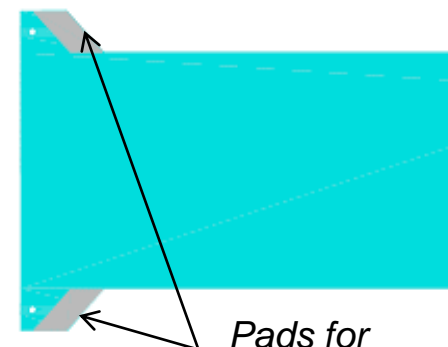
- v1) 300 um / 700 um;
- v2) 400 um / 600 um;
- v3) 500 um / 500 um.

Polyimide meshed spacer
(meshed area ~ 70%)



- v1) h=50 um;
- v2) h=75 um.

Shielding layer
(Al - 50 um)



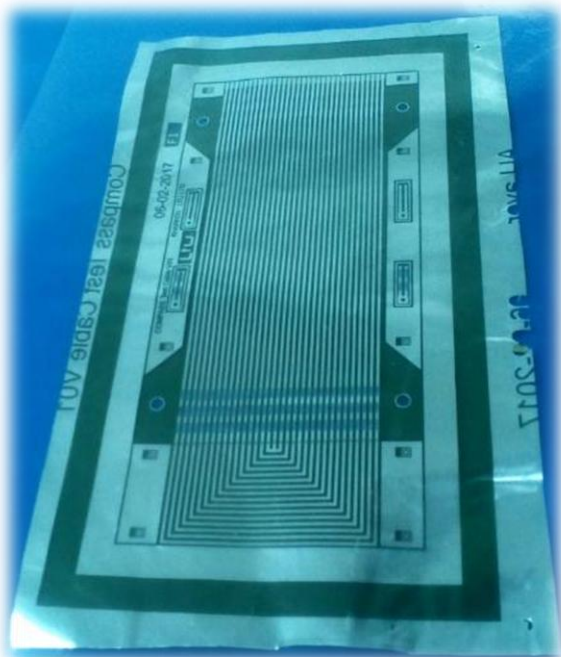
Pads for soldering

Activities for COMPASS: cable prototypes

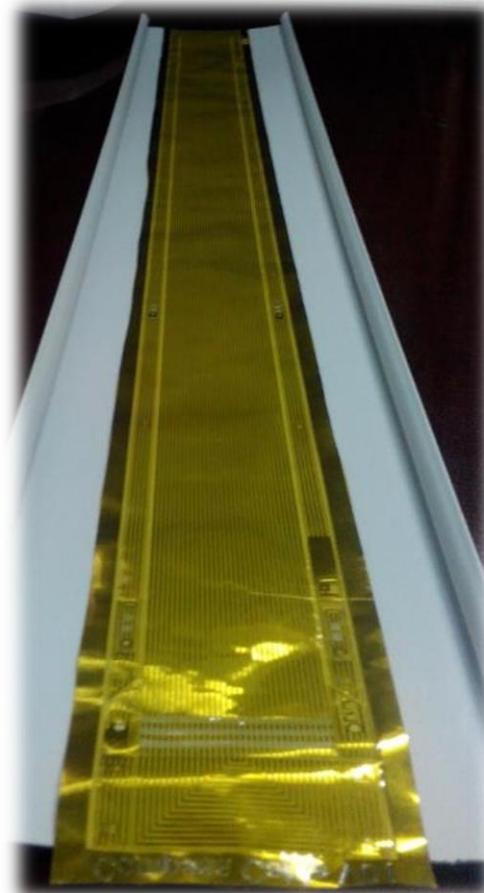


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Technological test cable
(~ 15 cm long)



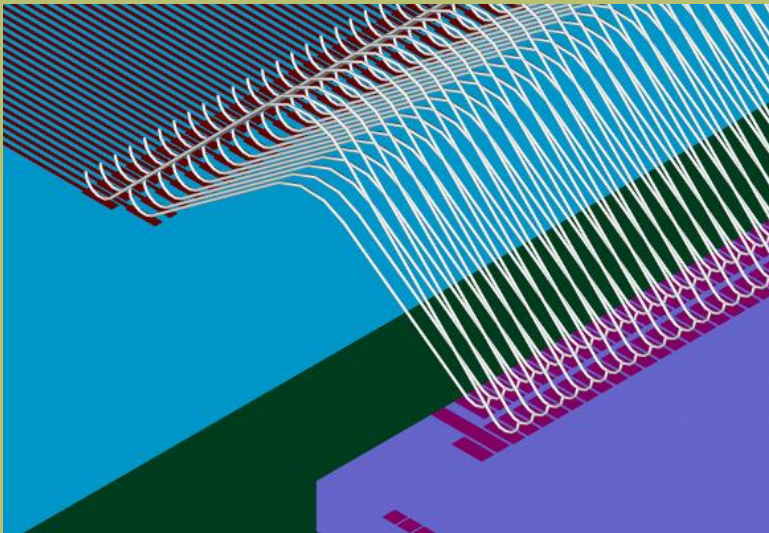
Cable prototype
(~ 65 cm long)



Type of connections

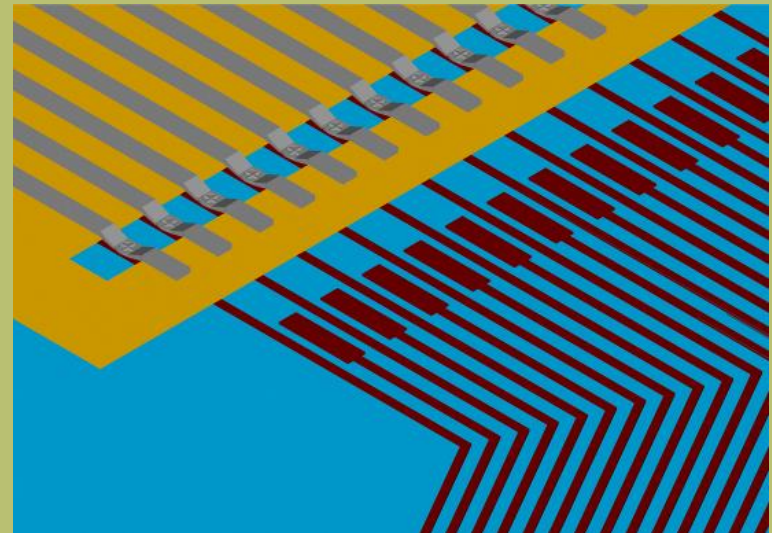
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Wires



Wire-welding to the aluminum-polyimide flexible board (FDI-A-50 - aluminum thickness is 30 μm) is possible

SpTAB



SpTAB of the aluminum-polyimide flexible board (FDI-A-50 - aluminum thickness is 30 μm , width of trace is 100 μm) to PCB contact pads is possible

Activities for other experiments

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❖ ALICE ITS upgrade

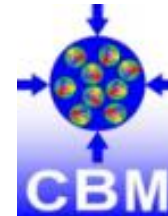


ALICE

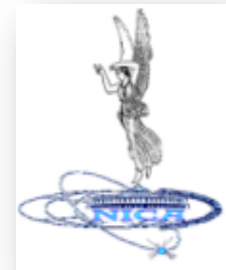
❖ LHCb IT upgrade



❖ CBM



❖ NICA/MPD



❖ PANDA



❖ Mu3e



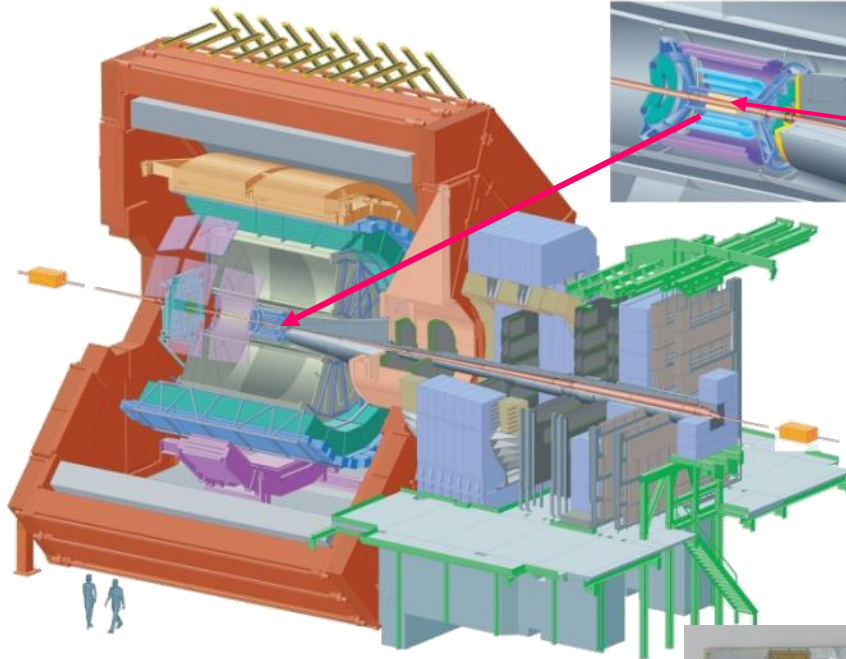
Activities for CERN:



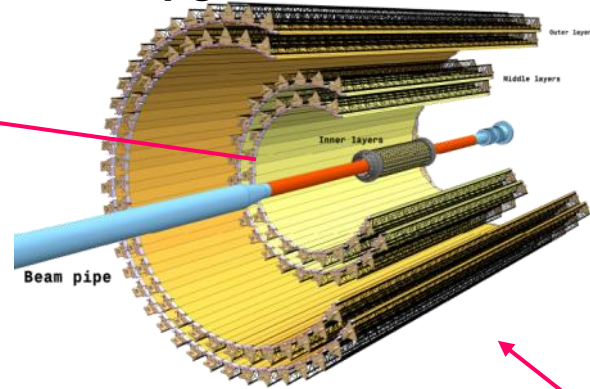
ALICE

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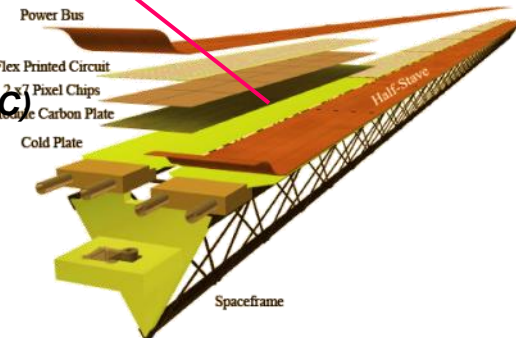
ALICE ITS upgrade



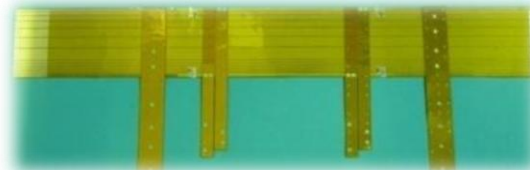
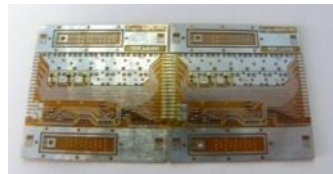
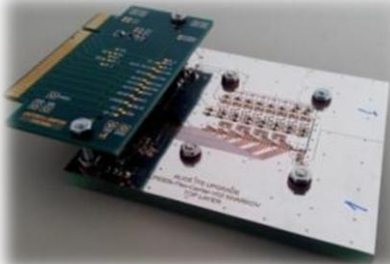
Upgraded ITS



Stave composition



- ✓ Power Bus
- ✓ Flexible printed circuit (FPC)

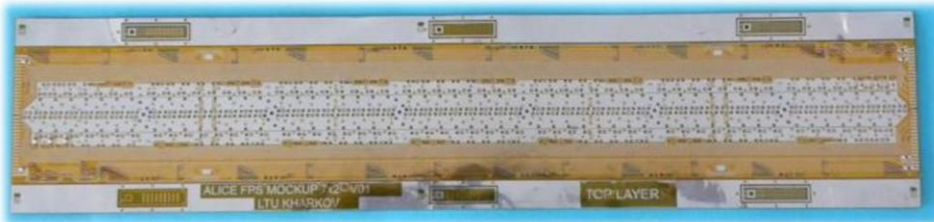


Mock-ups and prototypes for ALICE ITS Upgrade



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OB FPC prototype (for 14 MAPS, ~21 cm long)



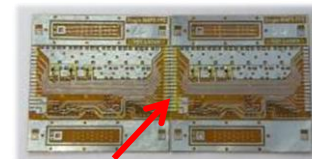
PB cross-cable prototype



IB FPC prototype (for 9 MAPS, ~45 cm long)



Inter-module connection (prototype)



OB PB prototype (for 6 HIC, ~1,5 m long)



Inter-module cable

Notes:

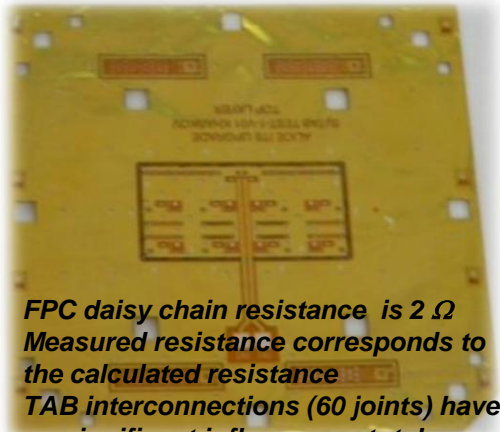
- All components are made of aluminium-polyimide adhesiveless materials
- Some own adhesiveless aluminium-polyimide materials are developed (Al 50um, 100um)

Prototypes for ALICE ITS upgrade: test results



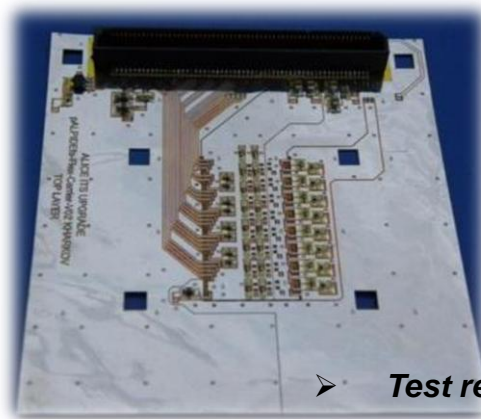
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FPC prototype

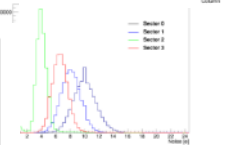
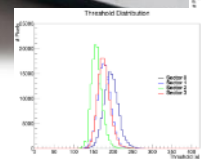
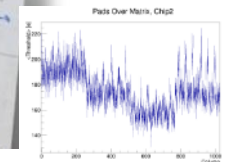
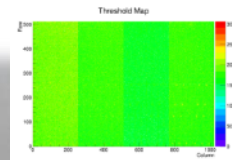
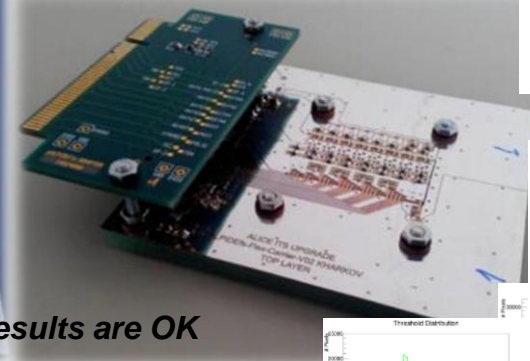


- FPC daisy chain resistance is $2\ \Omega$
- Measured resistance corresponds to the calculated resistance
- TAB interconnections (60 joints) have no significant influence on total resistance

Single-chip SpTAB FPC with pALPIDE chip

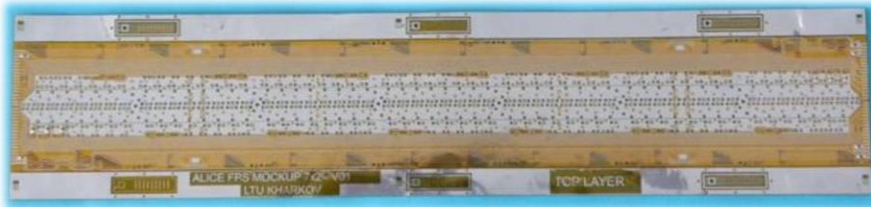


➤ Test results are OK



Module mock-up (14 MAPS 50um thick)

Side of the FPC



Side of chips



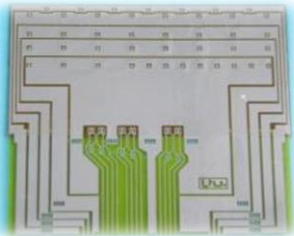
No damages or cracks were observed after assembling!



Activities for CERN FoCal

experiment

Cutout cable

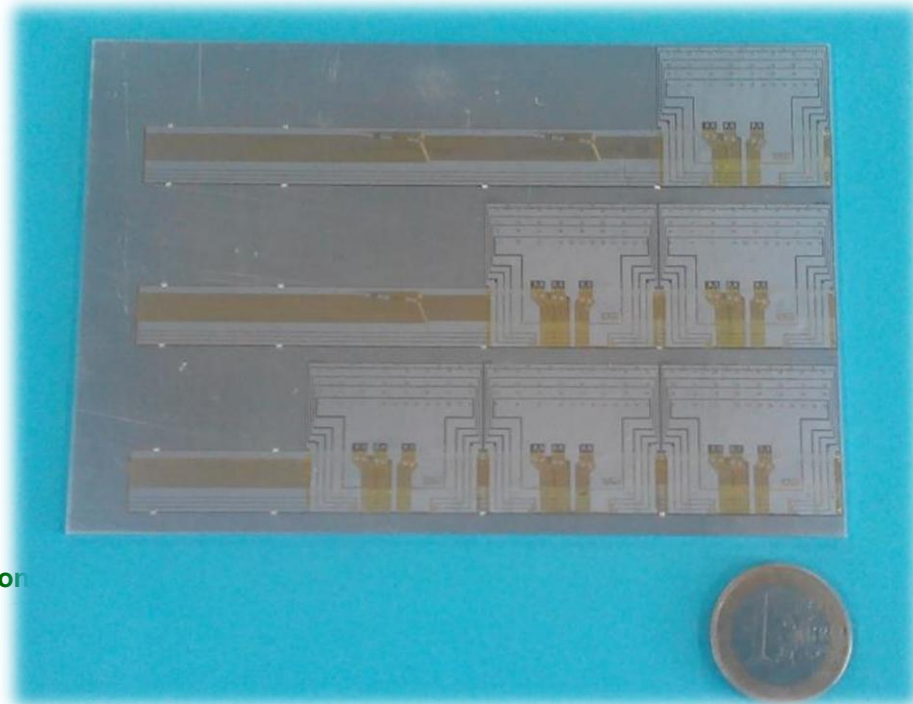


Carrier with multilayered flexes



Aligning,
Gluing,
SpTAB,
Testing,
Protecting bon

Assembled slab mock-up



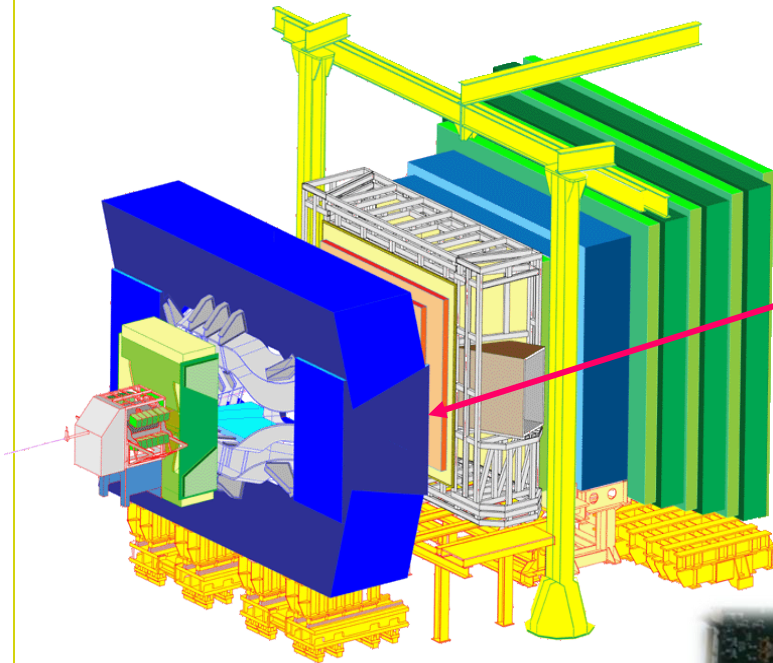
Joint activity with NIKHEF

Activities for CERN:



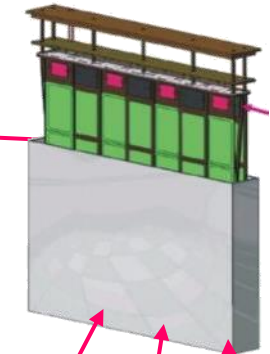
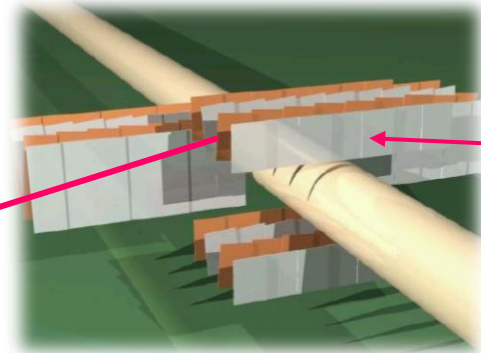
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LHCb IT upgrade



Inner Tracker

Detector box



Detector modules

Single sensor



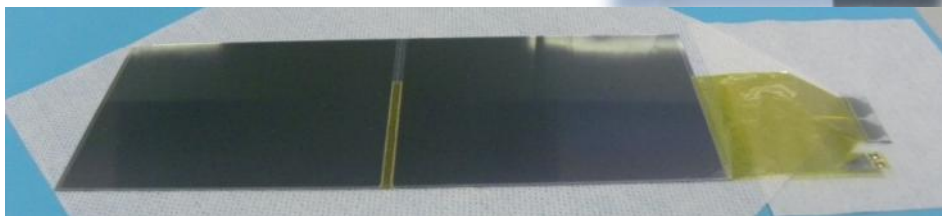
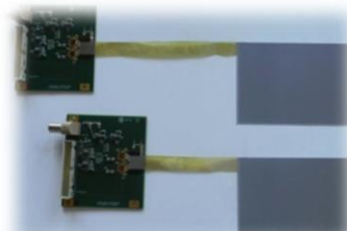
Double sensor



Triple sensor



- ✓ Connecting cable
- ✓ Inter-sensor cable



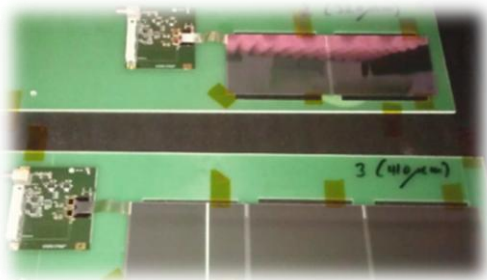
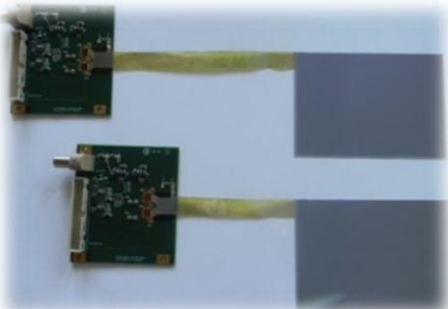
LHCb IT upgrade: prototypes



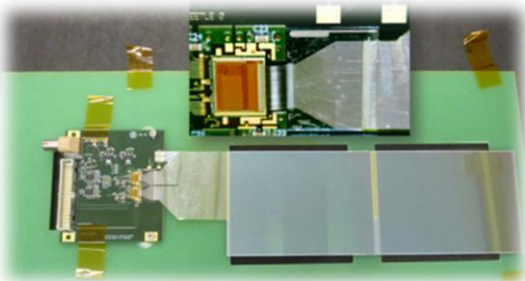
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module prototypes

64 ch

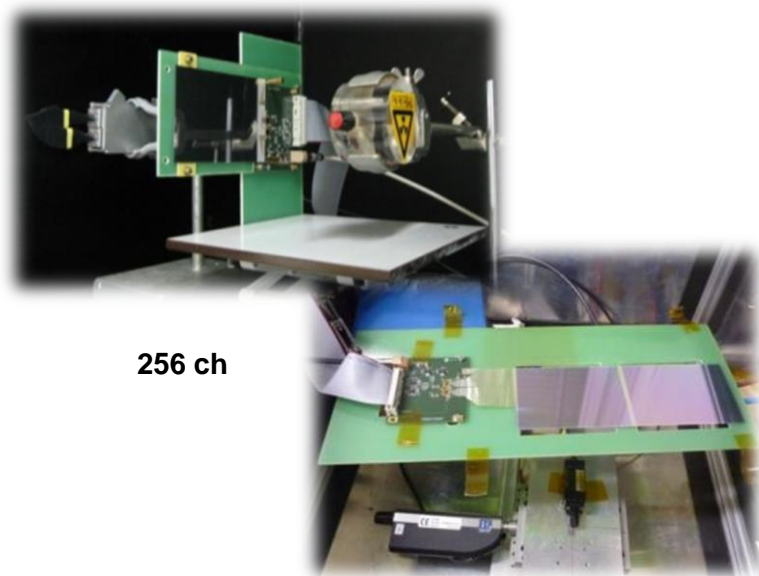


256 ch



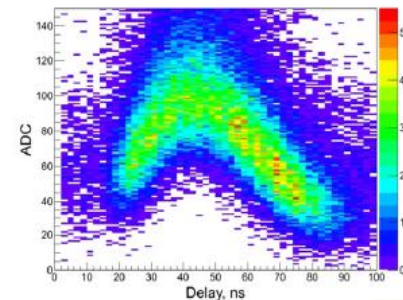
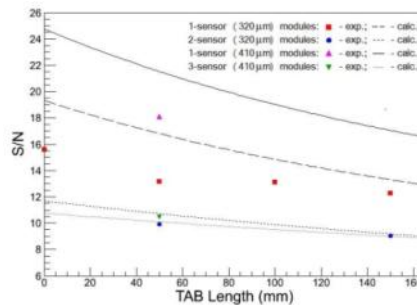
module prototypes under testing (CERN)

64 ch



256 ch

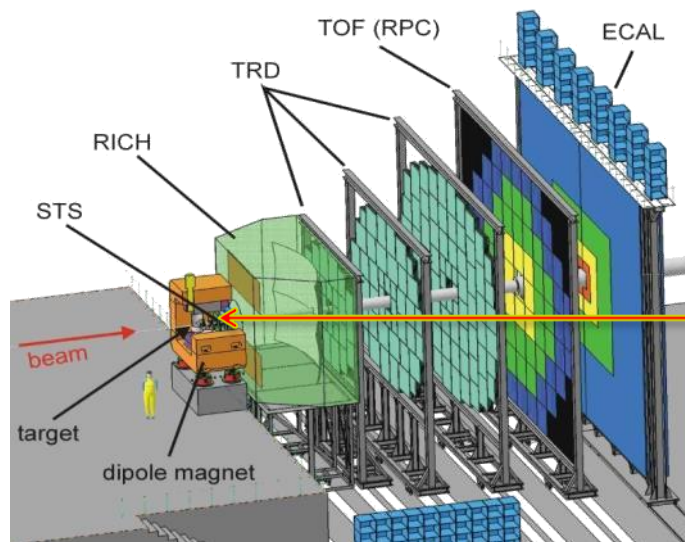
Module prototypes: test results



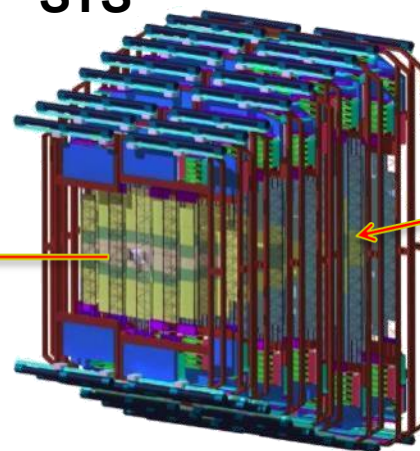
Activities for GSI:

22

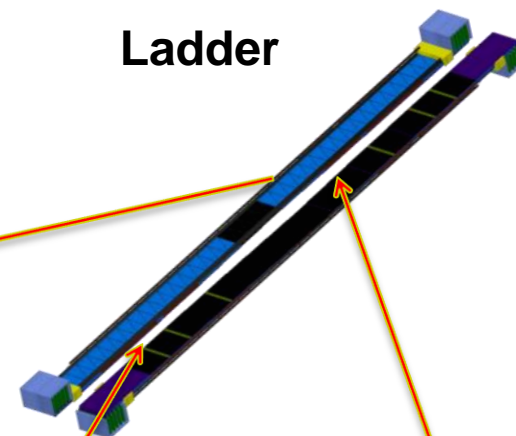
CBM experiment



STS

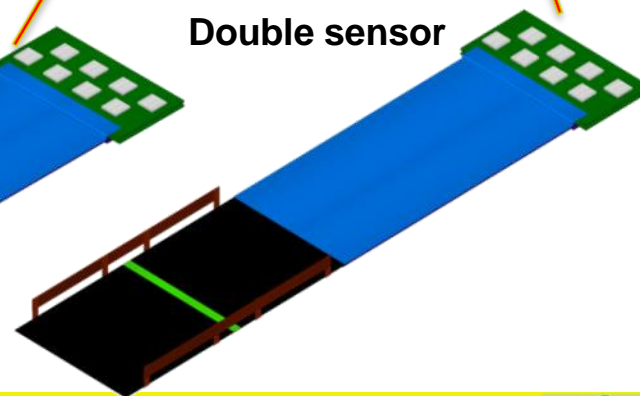


Ladder

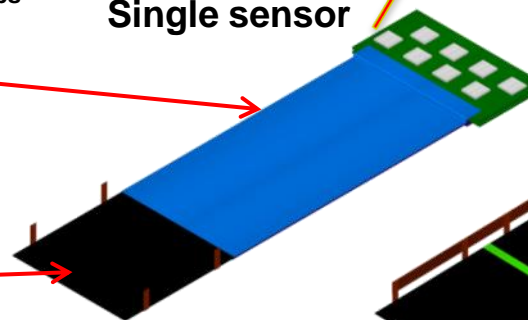


Detector modules

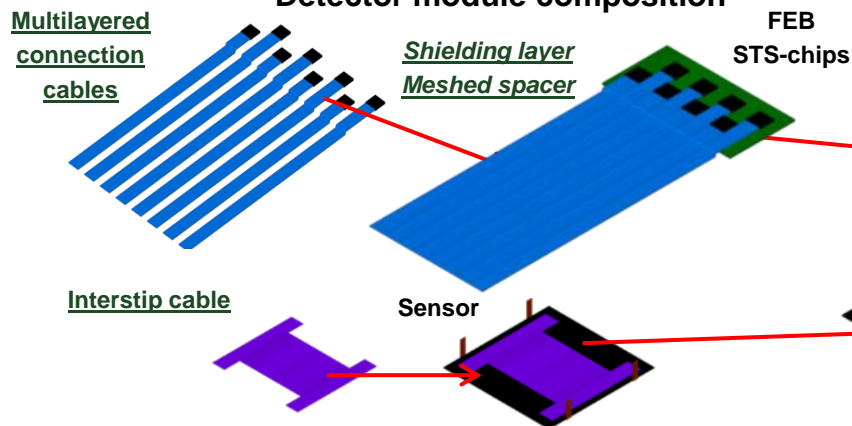
Double sensor



Single sensor

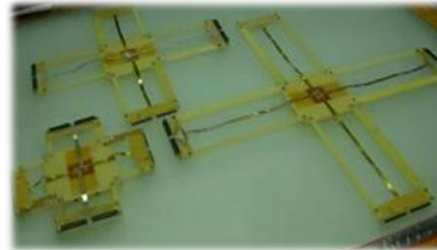
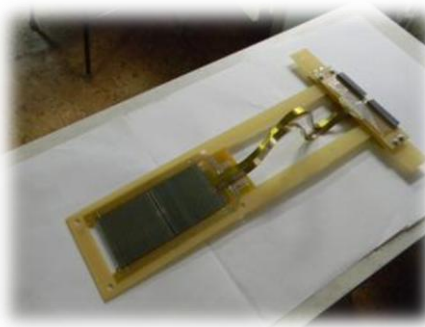
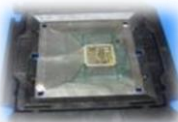
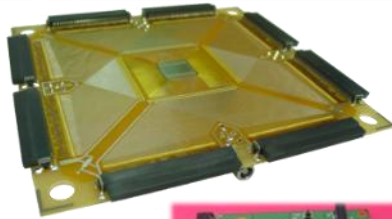
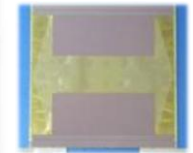
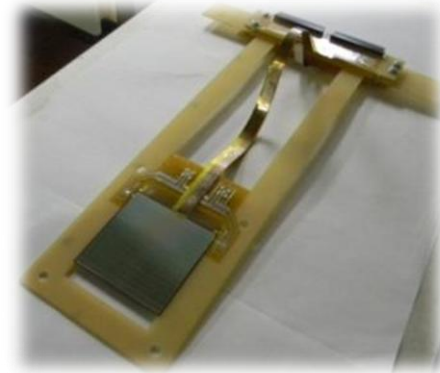
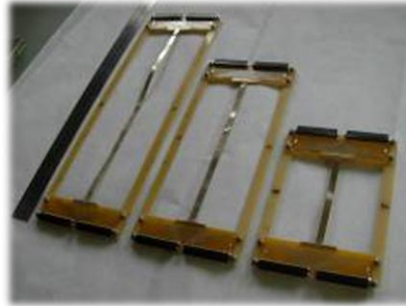
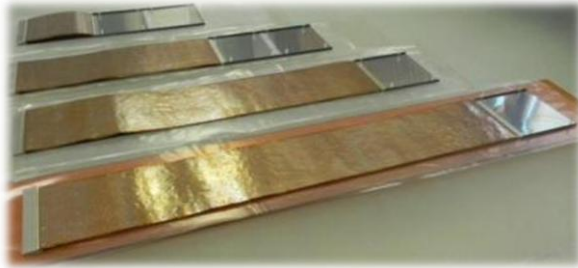


Detector module composition

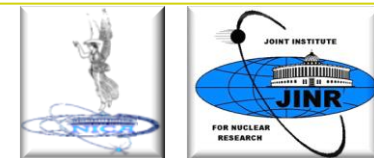


Mock-ups and demonstrators (CBM)

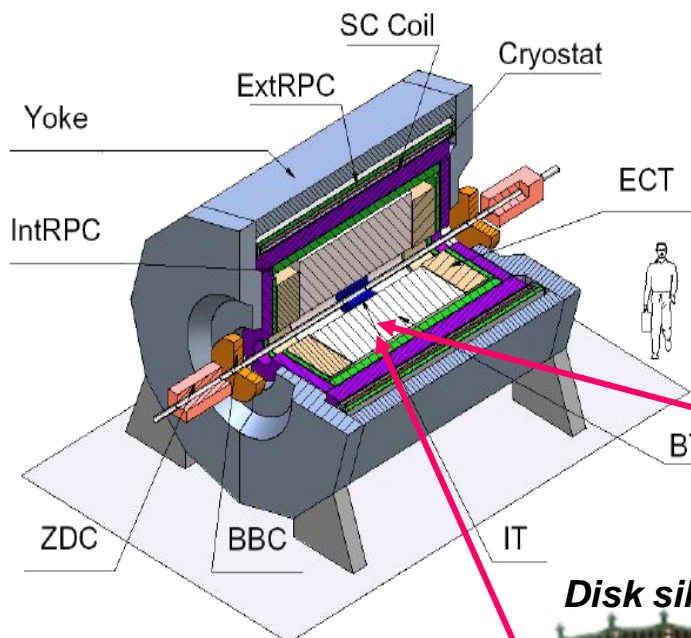
23



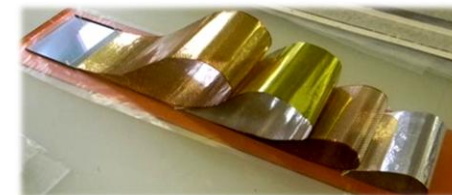
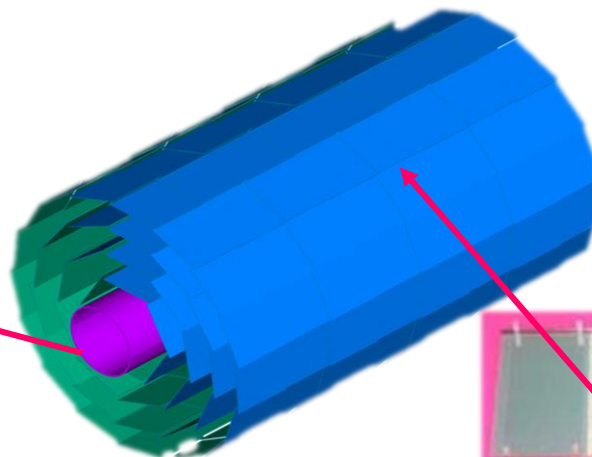
Activities for JINR: NICA experiment



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Barrel silicon tracking system

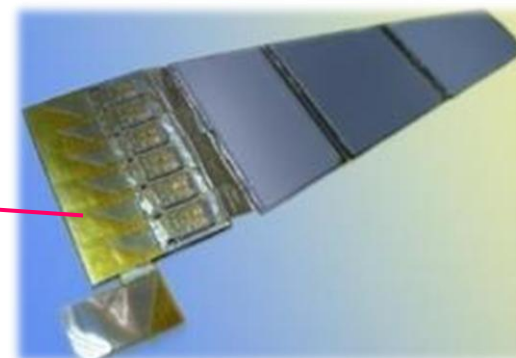
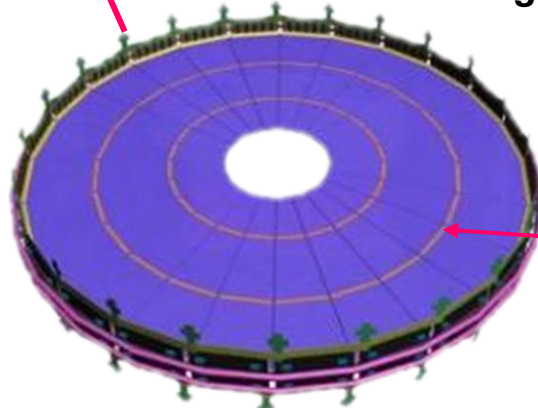


Multisensor detector module



Multisensor detector module

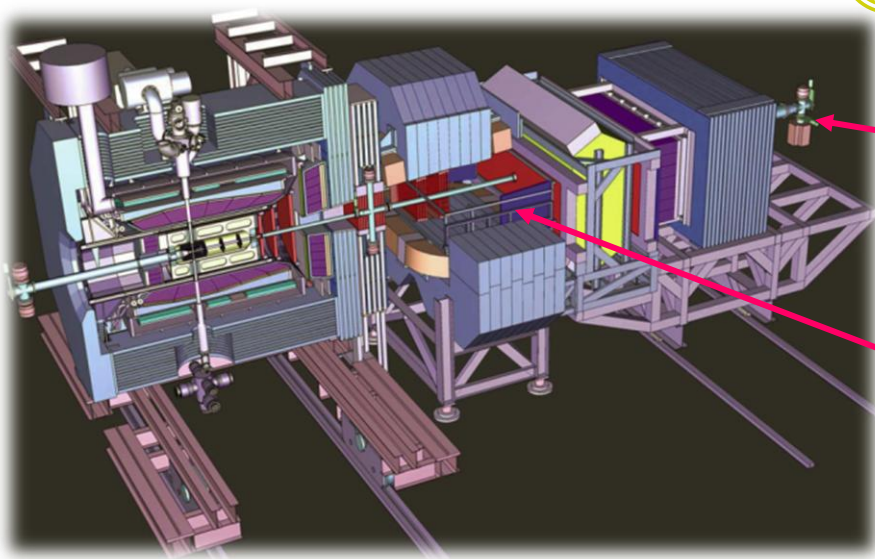
Disk silicon tracking system



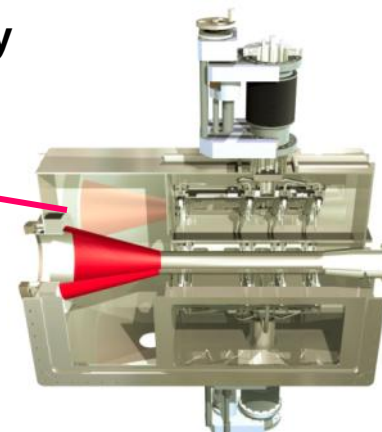
Activities for GSI: PANDA

25

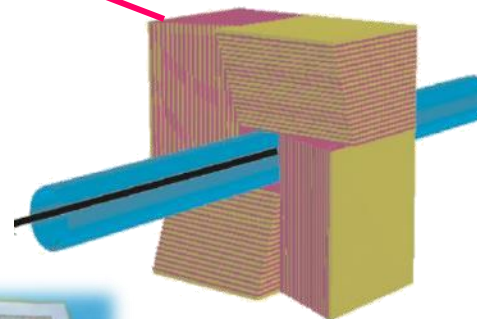
experiment



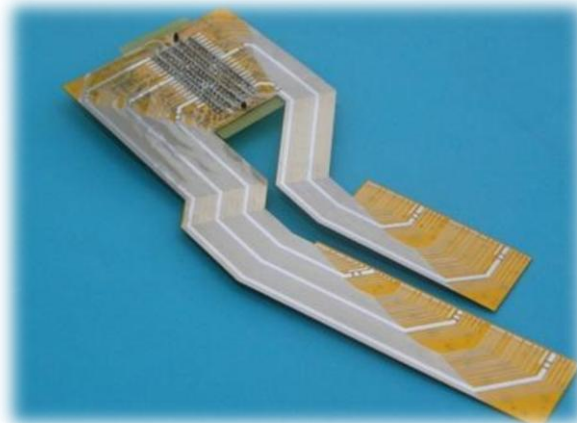
Luminosity
detector



Secondary
target



Joint activity with University of Mainz



Activities for PSI: Mu3e

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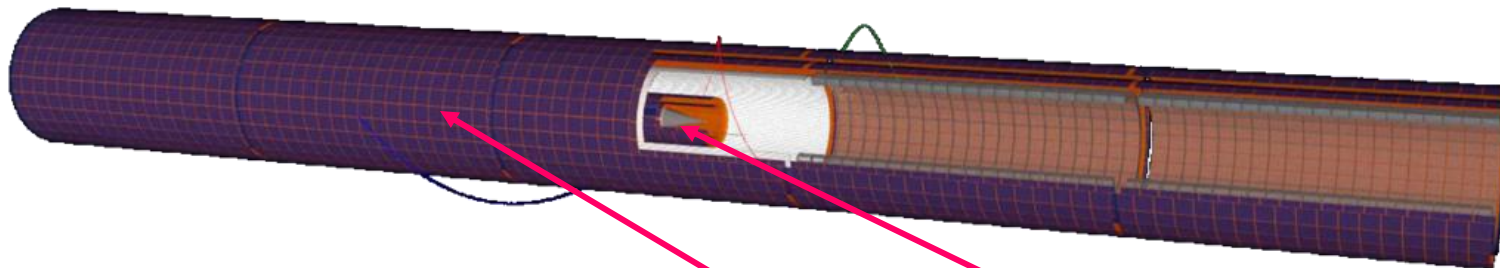
PAUL SCHERRER INSTITUT



experiment



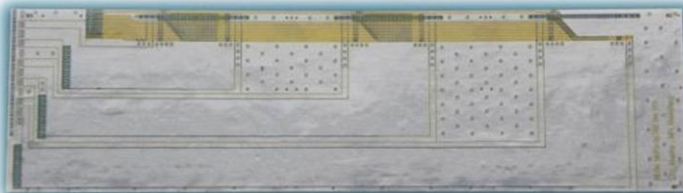
The Mu3e detector



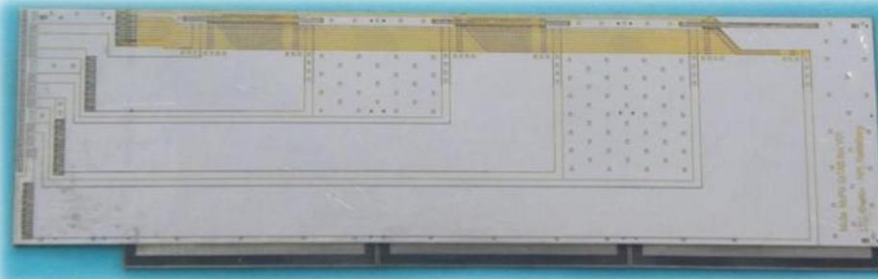
Inner detector layer

Outer detector layer

Mu3e FPC



Mechanical mock-up of Mu3e pixel detector module



*Joint activity with Heidelberg Physics Institute
University of Heidelberg*

Conclusions

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- ❖ Kharkiv team is experienced team in development and creation of detector modules and their components for physics experiments
- ❖ Main part of activities of Kharkiv team are single- and multilayered flexible boards and cables and also assembly procedures
- ❖ Activities for Compass are ongoing

**Thanks a lot
for your attention!**

Backup slides

Kharkiv team capabilities

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For works on detector modules and components creation at LTU Ltd two well equipped sites are available

- ***Cable production site (~110sq.m, incl. 20 sq.m clean room)***

for development and production components of detector modules (flexible cables and boards, dielectric spacers etc.). Manufacture technology based on photolithography and wet chemical etching.

- ***Microelectronics devices assembly site (~110sq.m)***

for detector modules and components assembling (multilayered flexible and flexible-rigid boards etc.). Assembly technology based on SpTAB.

Microcable production site

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substrates preparing



*photoresist coating,
exposing, developing*



*Wet chemical
etching*



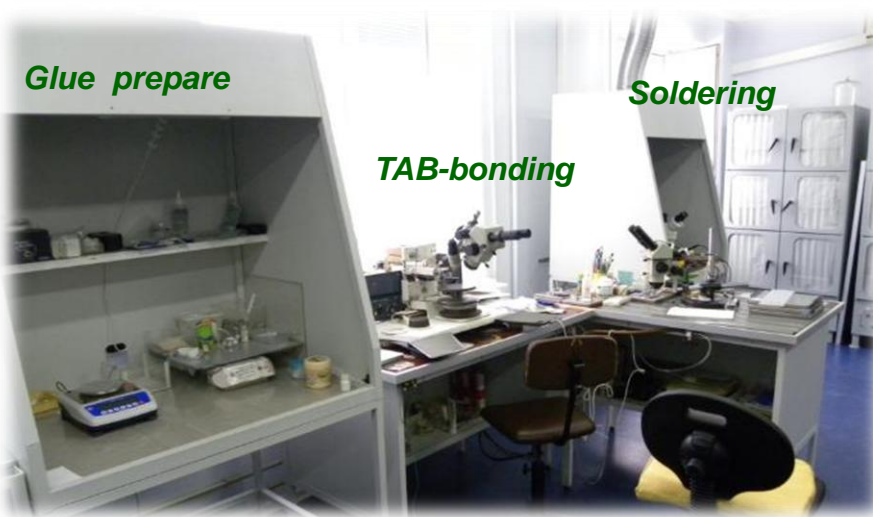
(clean room)



*Visual
inspection*

Microelectronics devices assembly site

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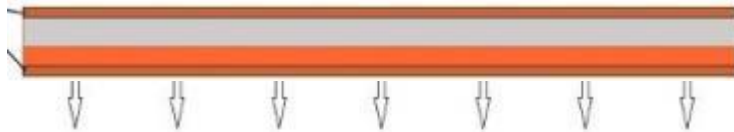


Cable production- technological steps

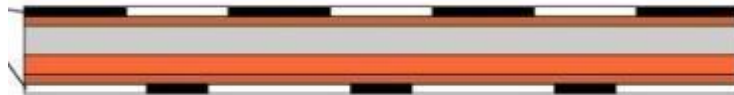
33



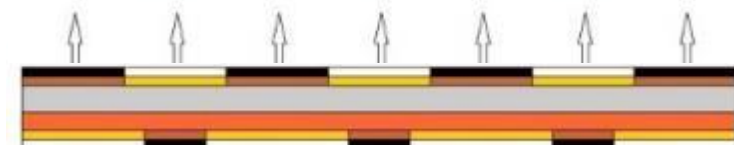
Flexible substrate preparing



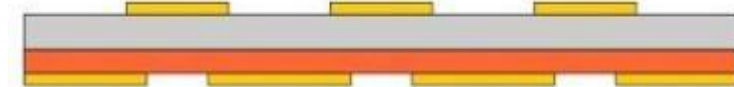
Double side photoresist coating



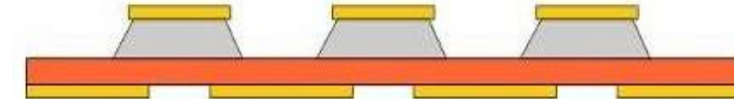
Double side exposing



Photoresist development



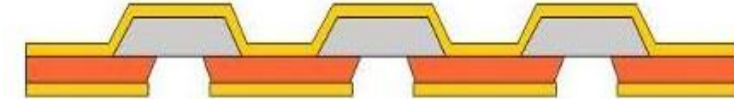
Aluminium etching



Photoresist coating for aluminium protection



Polyimide etching



Photoresist removing, inspection

